

part of
27

Attorney's Docket No.: 07977-192001
Client's Ref. No.: US3444

OFFICIAL COMMUNICATION

FACSIMILE

FOR THE PERSONAL ATTENTION OF:

EXAMINER HU, S.

GROUP 2811 FAX NO: 703-872-9318

Number of pages including this page 31

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JAN 27 2003

TECHNOLOGY CENTER 2800

Applicant : Hisashi Ohtani, et al.
Serial No. : 08/958,568
Filed : October 28, 1997

Art Unit : 2811
Examiner : Hu, S.
Confirmation No.: 3554

FACSIMILE COMMUNICATION

Title : SEMICONDUCTOR DEVICE AND METHOD OF FABRICATING THE SAME

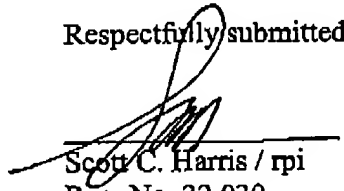
Commissioner for Patents
Washington, D.C. 20231

Sir:

Attached to this facsimile communication cover sheet is a Response to Office Action, faxed this 27th day of January, 2003, to Group 2811, the United States Patent and Trademark Office.

Respectfully submitted,

Date: January 27, 2003


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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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SAME

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RESPONSE

In response to the official action mailed 09/25/02, paper
no. 26 in the above referenced case, please amend the
application as follows:

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TECHNOLOGY CENTER 2800

In the claims:

In the pending claims, please amend claims 61, 73-76, 83,
85, 86, 87 and 95-101 as follows.

61. (Amended) A display device comprising:

a semiconductor island comprising silicon provided on an
insulating surface;

a source region and a drain region provided in said
semiconductor island;

a channel region provided in said semiconductor island
between said source region and said drain region;

CERTIFICATE OF TRANSMISSION BY FACSIMILE

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Trademark Office on the date indicated below.

January 27, 2003

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